

Approved Agenda

ASC OP/TF 2 – Committee for Optics and Electro-Optical Instruments – Appearance Imperfection Standard Meeting

May 11, 2009, 8:30 a.m. – 12 Noon
Rochester Convention Center, Aqueduct Room
123 Main St E
Rochester, NY 14604

1. Welcome and Introductions G. Boulton
2. Adoption of Agenda G. Boulton
3. Approval of the January 25, 2009, ASC OP/TF 2 Committee for Optics and Electro-Optical Instruments, Fundamental Standards – Appearance Imperfection Standard minutes G. Kohlenberg
4. Status of Release of ANSI/OEOSC OP1.002-2009 (Rev 2006) G. Kohlenberg
5. Report on visit by OEOSC representatives to Picatinny Arsenal in NJ (verbal supplement to trip report already published) D. Aikens
 - a) Action items resulting from the visit
6. Update on development of scratch inspection vision system being developed by Savvy Optics and Ari Siletz D. Aikens
7. Update of POG Standards D. Aikens
8. Review and discussion of inputs on New Work Item for Rev. 3 of OP1.002 A Krisiloff
 - a) Proposed method of microscopic inspection of scratches, originally proposed by REO in 2007 D. Aikens
9. Status of One-Hour Overview Presentation on the various scratch and dig standards A. Krisiloff
10. Time and Place for next OP/TF 2 Meeting: G. Boulton
Suggestions: **San Diego, CA**, (SPIE Annual Meeting), August 2 or 3, 2009, **San Jose, CA**, (OSA Annual Meeting), October 11 or 12, 2009

